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17613 U.S. PTO

PATENT APPLICATION
Docket No. 9898-277
Client No. SS-17652-US

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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I HEREBY CERTIFY THAT THIS PAPER AND ENCLOSURES AND/OR FEE ARE BEING DEPOSITED WITH THE UNITED STATES POSTAL SERVICE "EXPRESS MAIL POST OFFICE TO ADDRESSEE" SERVICE UNDER 37 CFR 1.10 ON THE DATE INDICATED ABOVE AND IS ADDRESSED TO: MAIL STOP PATENT APPLICATION, COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450.

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Mail Stop Patent Application
Commissioner for Patents
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Enclosed for filing is a patent application under 37 CFR 1.53(b) of:

Inventor: Jae-Kyu Lee

For: METHOD FOR FORMING SHALLOW WELL OF SEMICONDUCTOR DEVICE USING LOW-ENERGY ION IMPLANTATION

Applicant requests FIG. 6 to be published with the application.

Enclosures:

- Specification (pages 1-9); claims (pages 10-13); abstract (page 14)
 Certified copy of Priority Document No. 2002-43698, filed July 24, 2002
 Return Postcard
 SIX sheet(s) of FORMAL drawings (comprising 13 figures)

CLAIMS AS FILED

For	Number Filed	Number Extra	Rate	Basic Fee \$750
Total Claims	20-20	0	x \$ 18 =	\$0.00
Independent Claims	4-3	1	x \$ 84 =	\$84.00
TOTAL FILING FEE				\$834.00

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Respectfully submitted,

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